

03560.002597.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Prior Examiner: Courtney D. Thomas
HIDEYUKI CHINJU, et al.)	
	:	Prior Group Art Unit: 2882
Application No.: Not Yet Assigned)	
	:	
Filed: Concurrently Herewith)	
	:	
For: SYNCHROTRON RADIATION)	
MEASUREMENT APPARATUS,	:	
X-RAY EXPOSURE)	
APPARATUS, AND DEVICE	:	
MANUFACTURING METHOD)	October 20, 2003

Box Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese Priority Applications:

Japan 11-157038, filed June 3, 1999; and

Japan 11-170050, filed June 16, 1999.

Applicants' undersigned attorney may be reached in our Costa Mesa,
California office by telephone at (714) 540-8700. All correspondence should continue to
be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 32622

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200

CA_MAIN 71850 v 1